Electronic Patent Application Fee Transmittal							
Application Number:	10798331						
Filing Date:	12-Mar-2004						
Title of Invention:	METHOD FOR MANUFACTURING SPUTTER-COATED SUBSTRATES, MAGNETRON SOURCE AND SPUTTERING CHAMBER WITH SUCH SOURCE						
First Named Inventor/Applicant Name:	Stanislav Kadlec						
Filer:	Ronald J. Shore/Elizabeth Lee						
Attorney Docket Number:	635.43483X00						
Filed as Large Entity							
Utility under 35 USC 111(a) Filing Fees							
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Utility Appl issue fee		1501	1	1510	1510		
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